#### EMISSION SOURCES - MAXIMUM ALLOWABLE EMISSION RATES

### Permit No. 1618

This table lists the maximum allowable emission rates and all sources of air contaminants on the applicant's property covered by this permit. The emission rates shown are those derived from information submitted as part of the application for permit and are the maximum rates allowed for these facilities. Any proposed increase in emission rates may require an application for a modification of the facilities covered by this permit.

#### AIR CONTAMINANTS DATA

Emission <u>*</u>	Source	Air Contaminant	Emission	Rates
Point No. (1)	Name (2)	Name (3)	lb/hr	TPY
				0.64
EPN 1A/1B	Maskant Spray Booths Stacks (5)	PM	0.32	0.64
		PM <sub>10</sub>	0.32	0.64
		Perchloroethylene		7.86
		0XS0L 100	15.61	4.51
		EGBE	1.62	3.28
		Toluene	5.85	5.92
		Naphtha	17.77	17.96
		Xylene	0.11	0.22
EPN 2	Sludge Dryer Scrubber Ve <0.01	Vent	РМ	0.01
		PM <sub>10</sub>	0.01	<0.01
EPN 4F	Building 1 (4)	Acetic Acid	0.044	0.01
	5 , ,	Acetone	0.62	0.07
		MEK	0.62	0.07
EPN 1F	Building 5 (4)	Acetic Acid	0.02	0.01
		Acetone	0.62	0.07
		MEK	0.62	0.07
			0.02	0107
EPN 5	Aluminum Chemical Mill Scrubber Stack	l PM	0.01	<0.01
		$PM_{10}$	0.01	<0.01
	(Building 1)	Aluminum	<0.01	<0.01
	_	Arsenic	<0.01	<0.01
		Chromium VI	<0.01	<0.01
		Copper	<0.01	<0.01
		Manganese	<0.01	<0.01
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Emission *	Source	Air Contaminant	Emission	Rates
- Point No. (1)	Name (2)	Name (3)	1b/hr	<u>TPY</u>
		Nickel Sodium Hydroxide	<0.01 0.01	<0.01 <0.01
EPN 6	Steel Chemical Mill Scrubber Stack (Building 3)	Hydrochloric Acid Hydrofluoric Acid Nitric Acid NO <sub>x</sub>		<0.01 <0.01 <0.01 1.30
EPN 7	Steel Chemical Mill Scrubber Stack (Building 3)	Hydrochloric Acid Hydrofluoric Acid Nitric Acid NO <sub>x</sub>		<0.01 <0.01 0.20 18.60
EPN 8	Titanium Chemical Mi Scrubber Stack (Building 4)	ll Hydrofluoric Acid Nitric Acid NO <sub>x</sub>	0.23 0.06 0.88	0.70 0.20 0.30
EPN 9	Hydrochloric Acid Ta 0.10	nk (4) Hydrochloric A	cid	0.02
EPN 10	Nitric Acid Tank (4)	Nitric Acid	0.01	<0.01
EPN 11	Aluminum Chemical Mi Filter Stack (Building 7)	ll PM <sub>10</sub> Sodium Hydroxide Aluminum Triethylanolamine Arsenic	<0.01 e<0.01	0.20 0.06 0.01 0.01 <0.01
EPN 12	Horizontal Dip CAS Stack (Building 7) (5)	PM <sub>10</sub> Perchloroethylene Toluene Naphtha Xylene OXSOL 100	0.85 12.94 6.31 0.55 0.29 8.48	0.06 25.91 4.78 3.59 0.72 7.04

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		EGBE 4.33	3.28				
EPN 13F	Building 7 (4)	Acetic Acid Acetone MEK	0.044 0.62 0.62	0.01 0.07 0.07			
(1)	Emission point identi gnation or emission poi			uipment			
(2)	Specific point source or fugitive source nam	name. For fugitive		se area			
	$NO_x$	<u>-</u>	total oxi	des of			
PM	- particulate matter,	suspended in the atm	osphere, in	cluding			
PM <sub>10</sub> - particulate matter equal to or less than 10 microns in diameter. Where PM is not listed, it shall be assumed that no particulate matter greater than 10 microns is emitted.  OXSOL 100 - parachlorobenzotrifluoride  EGBE - ethylene glycol monobutyl ether, 2-butoxyethanol  - methyl ethyl ketone  (4) Fugitive emissions are an estimate only and should not be considered as a maximum allowable emission rate.  The sum of the total annual perchloroethylene emissions from both of these emission points is limited to 26 tons per year.  * Emission rates are based on and the facilities are limited by the following maximum operating schedule:							
24 Hrs/year	Hrs/day <u>6</u> Days/	/week <u>52</u> Weeks/y	/ear or	7,488			

Dated\_\_\_\_